



FIG. 1

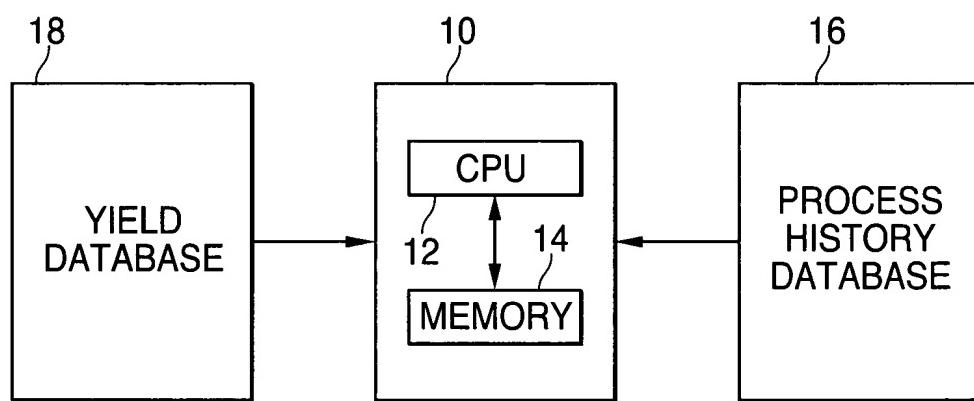


FIG. 2

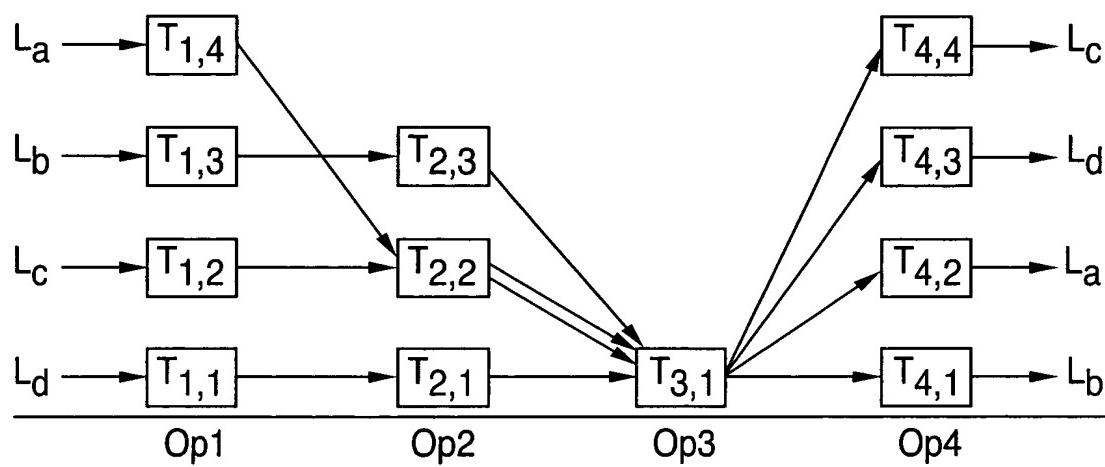


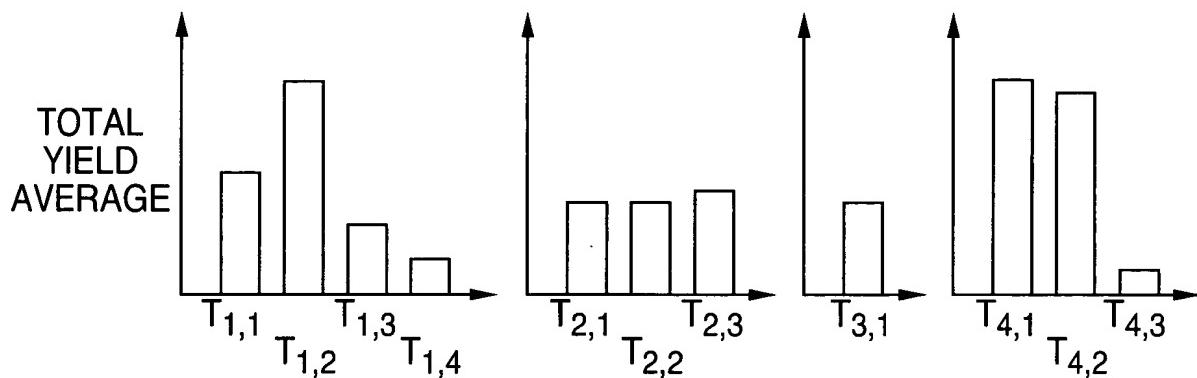


FIG. 3

LOT: L _a		PROCESS FLOW = PF101				
OPERATION		Op1	Op2	Op3	Op4	-----
TOOL		T _{1,4}	T _{2,2}	T _{3,1}	T _{4,2}	-----
WAFER		W _{a,1}	W _{a,2}	W _{a,3}	W _{a,4}	-----
YIELD		Y _{a,1}	Y _{a,2}	Y _{a,3}	Y _{a,4}	-----

Da

FIG. 4



**FIG. 5**